



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Akiharu MIYANAGA et al.) Group Art Unit: 1762
Serial No. 10/728,987)
Filed: December 8, 2003) Examiner: W. Markham
For: PULSED PLASMA CVD METHOD)
FOR FORMING A FILM) Confirmation No.: 1100
(as amended))

**SUBMISSION OF A LISTING OF REFERENCES CITED IN PARENT
APPLICATIONS, PURSUANT TO MPEP 609(I)(A)(2)**

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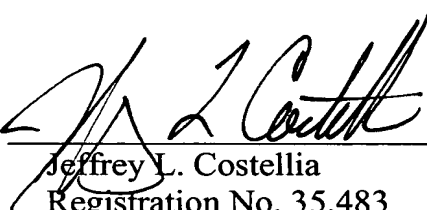
Sir:

The Applicants submit a listing of each of the references cited in parent Application No. 09/636,222, as well predecessor Application Nos. 09/262,853; 08/740,140; 08/463,058; 08/426,483; 08/120,222 and 07/763,595. The MPEP Chapter 609 @ (I)(A)(2) sets forth that each of the references from the predecessor applications must be considered by the Examiner, and, further, sets forth that if those references are to be printed on any issued patent from the above identified application, then a "listing" of those references must be provided by the Applicants. Please find attached a listing of each of the references cited in each of the parent (predecessor) applications.

It is respectfully requested that the Examiner provide, in the next Office Action, an indication of his consideration of each reference listed on the attached PTO-1449A forms by providing a properly initialed copy of each PTO-1449A form.

Respectfully submitted,

By:

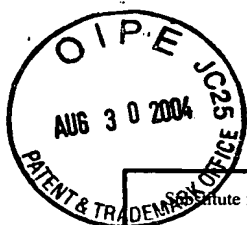


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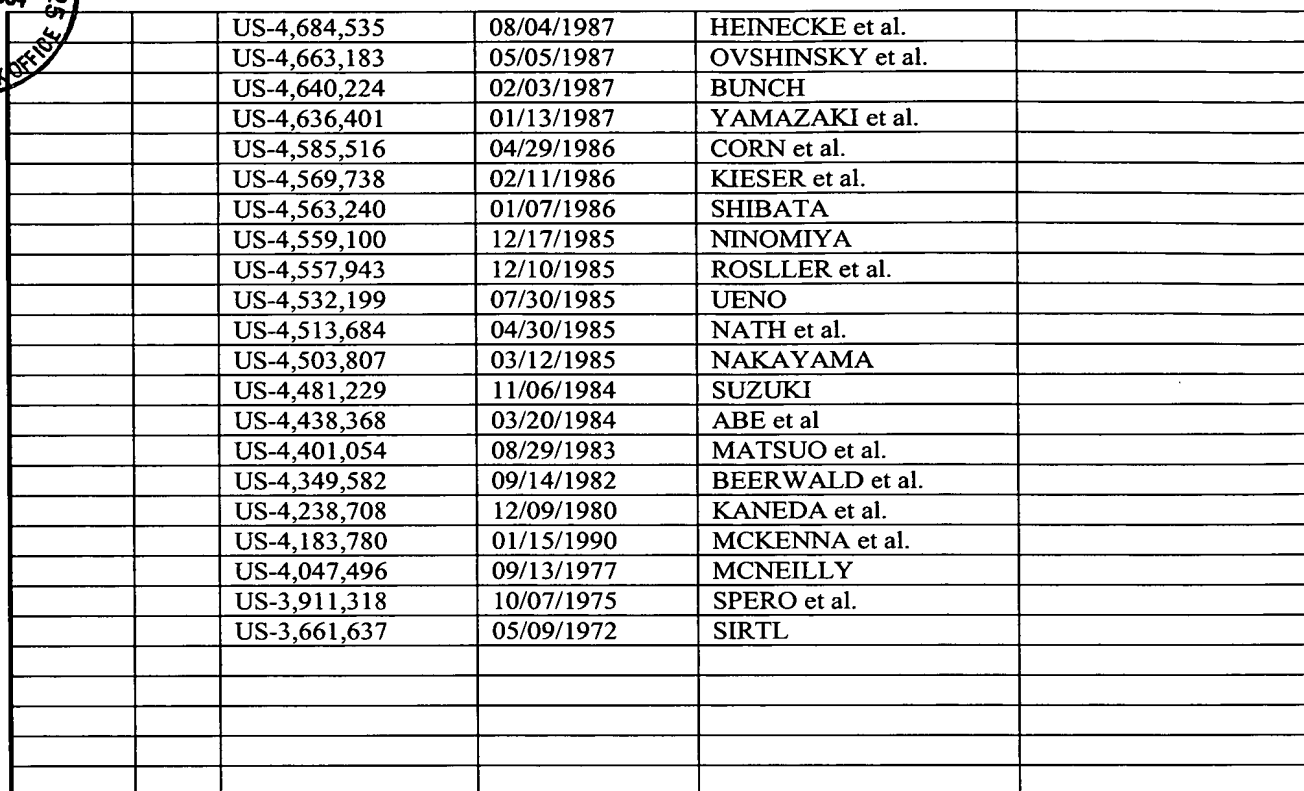
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Institute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	10/728,987
				Filing Date	December 8, 2003
				First Named Inventor	A. MIYANAGA et al.
				Art Unit	1762
				Examiner Name	Wesley D. Markham
				Attorney Docket Number	740756-2681
Sheet	1	of	3		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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